

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lee, *et al.* Docket No.: 2001 P 11904 US
Serial No.: 09/988,183 Art Unit: 2814
Filed: November 19, 2001 Examiner: Ha, Nathan W.
Title: Formation of Dual Work Function Gate Electrode

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Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's
Final Office Action mailed August 2, 2004. Please amend the above-referenced application as
follows. This amendment does not raise any new issues.